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Shibin Jiang
Michel J. F. Digonnet
John W. Glesener
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Contents

xi Conference Committee

SESSION 1 GAIN MATERIALS I

- 7598 02 **Similar behaviors of sulfide and selenide-based chalcogenide glasses to form glass ceramics (Invited Paper)** [7598-01]
 L. Calvez, Lab. des Verres et Céramiques, CNRS, Univ. de Rennes 1 (France); C. Lin, Wuhan Univ. of Technology (China); M. Rozé, Lab. des Verres et Céramiques, CNRS, Univ. de Rennes 1 (France); Y. Ledemi, Lab. dos Materials Fôtonicos, Instituto de Quimica (Brazil); E. Guillevic, B. Bureau, Lab. des Verres et Céramiques, CNRS, Univ. de Rennes 1 (France); M. Allix, CEMHTI, CNRS, Univ. d'Orléans (France); X. Zhang, Lab. des Verres et Céramiques, CNRS, Univ. de Rennes 1 (France)
- 7598 03 **The influence of photonic mode density on the luminescence of erbium-doped optical materials (Invited Paper)** [7598-02]
 F. Song, Nankai Univ. (China) and Key Lab. of Weak Light Nonlinear Photonics (China); Q. Wang, Nankai Univ. (China), Key Lab. of Weak Light Nonlinear Photonics (China), and City Univ. of Hong Kong (Hong Kong, China); C. Ming, J. Tian, J. Xu, Nankai Univ. (China) and Key Lab. of Weak Light Nonlinear Photonics (China); S. Lin, E. Y. B. Pun, City Univ. of Hong Kong (Hong Kong, China)
- 7598 04 **Two-photon pumped random lasing in a dye-doped silica gel powder** [7598-03]
 S. García-Revilla, Univ. del País Vasco (Spain); Í. Solá, Univ. de Salamanca (Spain); R. Balda, Univ. del País Vasco (Spain); L. Roso, Univ. de Salamanca (Spain); D. Levy, M. Zayat, Instituto de Ciencia de Materiales de Madrid (Spain); J. Fernández, Univ. del País Vasco (Spain)
- 7598 05 **Spectral and luminescent properties of Bi-doped bulk glasses and factors acting on them** [7598-04]
 B. I. Denker, B. I. Galagan, I. L. Shulman, S. E. Sverchkov, A.M. Prokhorov General Physics Institute (Russian Federation); E. M. Dianov, Fiber Optics Research Ctr. (Russian Federation)
- 7598 06 **Generation of wide color gamut visible light in NIR-excited thulium-holmium-ytterbium codoped tantalum oxide nanopowders** [7598-48]
 A. S. Gouveia-Neto, L. A. Bueno, E. B. Costa, E. A. Silva, Jr., Univ. Federal Rural de Pernambuco (Brazil); J. L. Ferrari, K. O. Lima, R. R. Gonçalves, Univ. de São Paulo (Brazil)

SESSION 2 GAIN MATERIALS II

- 7598 07 **Application of ceramic phosphors for near infrared biomedical imaging technologies (Invited Paper)** [7598-05]
 K. Soga, K. Tokuzen, K. Tsuji, T. Yamano, N. Venkatachalam, H. Hyodo, H. Kishimoto, Tokyo Univ. of Science (Japan)

- 7598 08 **White LED phosphors: the next step (Invited Paper)** [7598-06]
H. Yamamoto, Tokyo Univ. of Technology (Japan)
- 7598 09 **Construction of photoconductivity measurement system as functions of excitation wavelength and temperature: application to Eu²⁺-activated phosphors** [7598-07]
T. Nakanishi, S. Tanabe, Kyoto Univ. (Japan)
- 7598 0A **The efficiencies of energy transfer from Cr to Nd ions in silicate glasses** [7598-08]
S. Mizuno, H. Ito, K. Hasegawa, Toyota Central R&D Labs., Inc. (Japan); H. Nasu, M. Hughes, T. Suzuki, Y. Ohishi, Toyota Technological Institute (Japan)
- 7598 0B **The influence of Yb²⁺ ions on optical properties and power stability of ytterbium-doped laser fibers** [7598-09]
J. Kirchhof, S. Unger, A. Schwuchow, S. Jetschke, V. Reichel, M. Leich, A. Scheffel, Institute of Photonic Technology, Jena (Germany)

SESSION 3 SILICON TECHNOLOGY

- 7598 0C **Silicon photonic parametric optical processing for ultra-high bandwidth on-chip signal grooming (Invited Paper)** [7598-10]
A. Biberman, N. Ophir, K. Bergman, Columbia Univ. (United States)
- 7598 0D **Optical properties of atomic layer deposited materials and their application in silicon waveguides** [7598-11]
T. Alasaarela, Helsinki Univ. of Technology (Finland); J. Hiltunen, VTT Technical Research Ctr. of Finland (Finland); A. Khanna, A. Säynätjoki, A. Tervonen, S. Honkanen, Helsinki Univ. of Technology (Finland)
- 7598 0E **Silicon based 2-dimensional slot waveguides** [7598-12]
A. Khanna, T. Alasaarela, A. Säynätjoki, A. Tervonen, S. Honkanen, Helsinki Univ. of Technology (Finland)
- 7598 0F **Optical microresonator for application to an opto-electronic oscillator** [7598-13]
Y.-M. Wu, L. Vivien, E. Cassan, Institut d'Électronique Fondamentale, CNRS, Univ. Paris Sud 11 (France); V. H. N. Luong, L. D. Nguyen, B. Journet, SATIE, CNRS, École Normale Supérieure de Cachan (France)

SESSION 4 OPTICAL FIBERS AND DEVICES I

- 7598 0G **Recent developments in bend-insensitive and ultra-bend-insensitive fibers** [7598-14]
D. Boivin, L.-A. de Montmorillon, L. Provost, N. Montaigne, Draka Communications (France); F. Gooijer, E. Aldea, J. Jensma, Draka Communications (Netherlands); P. Sillard, Draka Communications (France)
- 7598 0H **Innovative fiber coating systems based on organic modified ceramics** [7598-15]
K. Schuster, J. Kobelke, Institute for Photonic Technology, Jena (Germany); K. Rose, Fraunhofer-Institut für Silicaforschung (Germany); M. Helbig, SurA Chemicals GmbH (Germany); M. Zoheidi, A. Heinze, FiberTech GmbH (Germany)

- 7598 0I **Novel shape memory alloy optical fibre connection method** [7598-16]
G. Trouillard, P. Zivojinovic, R. Cerutti, X. P. Godmaire, E. Weynant, Phasoptx Inc. (Canada)
- 7598 0J **Tunable birefringent phase shift induced in fiber Bragg gratings by a shape memory alloy phase modulator** [7598-17]
A. Fraser, PhasOptx (Canada) and Univ. Laval (Canada); M. Bernier, Univ. Laval (Canada); E. Weynant, PhasOptx Inc. (Canada); R. Vallée, Univ. Laval (Canada)
- 7598 0K **Novel fiber bottle microresonator add-drop filters** [7598-18]
G. Senthil Murugan, J. S. Wilkinson, M. N. Zervas, Univ. of Southampton (United Kingdom)

SESSION 5 OPTICAL FIBERS AND DEVICES II

- 7598 0L **Ultra-wideband integrated 2x2 optical router using novel MMI design** [7598-19]
M. A. Swillam, M. H. Bakr, X. Li, McMaster Univ. (Canada)
- 7598 0O **Fabrication of low losses chalcogenide photonic crystal fibers by molding process** [7598-22]
Q. Coulombier, Sciences Chimiques de Rennes, CNRS, Univ. de Rennes 1 (France); L. Brilland, PERFOS (France); P. Houizot, Sciences Chimiques de Rennes, CNRS, Univ. de Rennes 1 (France); T. N. Nguyen, T. Chartier, Ecole Nationale Supérieure des Sciences Appliquées et de Technologie (France); G. Renversez, Institut Fresnel, CNRS, Univ. St Jérôme (France); A. Monteville, PERFOS (France); J. Fatome, F. Smektala, Lab. Interdisciplinaire Carnot de Bourgogne, CNRS, Univ. de Bourgogne (France); T. Pain, Sciences Chimiques de Rennes, CNRS, Univ. de Rennes 1 (France); H. Orain, J.-C. Sangleboeuf, Lab. de Recherche en Mécanique Appliquée, CNRS, Univ. de Rennes 1 (France); J. Trolès, Sciences Chimiques de Rennes, CNRS, Univ. de Rennes 1 (France)

SESSION 6 PHOTONIC DEVICES I

- 7598 0P **Fabrication and characterization of colloidal crystals infiltrated with metallic nanoparticles** [7598-23]
A. Chiappini, CNR-IFN, CSMFO Lab. (Italy); S. Guddala, CNR-IFN, CSMFO Lab. (Italy), Univ. of Hyderabad (India), and Univ. degli Studi di Trento (Italy); C. Armellini, CNR-IFN, CSMFO Lab. (Italy) and FBK (Italy); S. Berneschi, I. Cacciari, MDF Lab., Istituto di Fisica Applicata Nello Carrara, CNR (Italy); C. Duverger-Arfulso, Lab. LdOF, CNRS, Univ. du Maine (France); M. Ferrari, CNR-IFN, CSMFO Lab. (Italy); G. C. Righini, MDF Lab., Istituto di Fisica Applicata Nello Carrara, CNR (Italy)
- 7598 0Q **Planar long-period gratings for photonic applications** [7598-24]
J. Jiang, C. L. Callender, C. J. Ledderhof, Communications Research Ctr. Canada (Canada); J. Ding, National Research Council Canada (Canada)
- 7598 0R **Time evolution of an electro-optic modulator by detection of its nonlinear behavior** [7598-25]
D. T. Bui, L. D. Nguyen, SATIE, CNRS, École Normale Supérieure de Cachan (France); I. Ledoux-Rak, LPQM, CNRS, École Normale Supérieure de Cachan (France); B. Journet, SATIE, CNRS, École Normale Supérieure de Cachan (France)
- 7598 0S **Compact Raman spectrometer system for low frequency spectroscopy** [7598-26]
C. Moser, F. Havermeier, Ondax, Inc. (United States)

- 7598 OT **A new class of polarization filters for laser applications** [7598-27]
L. Wang, C. Hodgson, T. Erdogan, Semrock, Inc. (United States)

SESSION 7 PHOTONIC DEVICES II

- 7598 OV **Serial pixel analog-to-digital converter (ADC)** [7598-30]
E. D. Larson, National Security Technologies, LLC (United States)

SESSION 8 DETECTOR TECHNOLOGIES I

- 7598 OX **Simulation based design for back-side illuminated ultrahigh-speed CCDs** [7598-32]
T. Arai, T. Hayashida, K. Kitamura, J. Yonai, H. Maruyama, NHK Science and Technology Research Labs. (Japan); N. Ohtsuka, C. Vo Le, T. G. Etoh, Kinki Univ. (Japan); H. van Kuijk, DALSA Corp. (Netherlands)
- 7598 OY **Modified uni-traveling-carrier photodiode-based V-band optoelectronic mixers with high up-converted power and high responsivity** [7598-33]
H. Pan, Z. Li, J. C. Campbell, Univ. of Virginia (United States)
- 7598 OZ **Dark count in single photon avalanche Si detectors** [7598-34]
R. Pagano, Univ. degli Studi di Catania (Italy) and Istituto per la Microelettronica e Microsistemi, CNR (Italy); S. Libertino, Istituto per la Microelettronica e Microsistemi, CNR (Italy); G. Valvo, G. Condorelli, B. Carbone, A. Piana, M. Mazzillo, D. N. Sanfilippo, G. G. Fallica, STMicroelectronics (Italy); G. Falci, Univ. degli Studi di Catania (Italy) and MATIS, CNR (Italy); S. Lombardo, Istituto per la Microelettronica e Microsistemi, CNR (Italy)

SESSION 9 DETECTOR TECHNOLOGIES II

- 7598 11 **DC and AC performance of leaky-mode metal-semiconductor-metal polysilicon photodetectors** [7598-36]
R. Pownall, Colorado State Univ. (United States); G. Yuan, Avago Technologies Ltd. (United States); C. Thangaraj, J. Kindt, T. W. Chen, Colorado State Univ. (United States); P. Nikkel, Avago Technologies Ltd. (United States); K. L. Lear, Colorado State Univ. (United States)
- 7598 12 **Ultra-high sensitivity photodetector arrays with integrated amplification and passivation nano-layers (Invited Paper)** [7598-37]
J. Yao, I. A. Mookina, F. Liu, S. Wang, J. Zhou, B&W Tek, Inc. (United States); M. Lange, Princeton Univ. (United States); W. Yang, P. Gardner, Western Carolina Univ. (United States); L. Peltz, R. Frampton, J. H. Hunt, The Boeing Co. (United States)
- 7598 13 **Back-thinned CMOS sensor optimization** [7598-75]
P. Jerram, D. Burt, N. Guyatt, e2v technologies plc (United Kingdom); V. Hibon, J. Vaillant, Y. Henrion, e2v semiconductors SAS (France)
- 7598 14 **Two micron pore size MCP-based image intensifiers** [7598-38]
J. Glesener, J. Estrera, L-3 Electro-Optical Systems (United States)

SESSION 10 SEMICONDUCTOR LASERS AND AMPLIFIERS

- 7598 15 **Progress in crystalline semiconductor core optical fibers (Invited Paper)** [7598-40]
J. Ballato, T. Hawkins, P. Foy, C. McMillen, R. Stolen, Clemson Univ. (United States); R. Rice, Northrop Grumman Space Technology (United States)
- 7598 17 **Pulse amplification in semiconductor optical amplifiers with ultrafast gain-recovery times** [7598-42]
P. P. Baveja, A. M. Kaplan, Institute of Optics, Univ. of Rochester (United States);
D. N. Maywar, Rochester Institute of Technology (United States); G. P. Agrawal, Institute of Optics, Univ. of Rochester (United States)
- 7598 18 **High-temperature stability of lasing wavelength in GaAsSb/GaAs double quantum wells lasers** [7598-43]
H.-C. Yu, C.-T. Wan, Y.-K. Su, R. W. Chuang, W.-C. Chen, C.-Y. Huang, W.-H. Lin, M. H. Pilkuhn, National Cheng Kung Univ. (Taiwan)
- 7598 19 **1.54 μ m emitter and optical amplifier based on Er doped InGaN/GaN** [7598-44]
R. Dahal, J. Y. Lin, H. X. Jiang, Texas Tech Univ. (United States); J. M. Zavada, North Carolina State Univ. (United States)

SESSION 11 LASER AND AMPLIFIERS I

- 7598 1A **Near and medium infrared optical fiber lasers and emerging applications (Invited Paper)** [7598-45]
F. Prudenzeno, L. Mescia, L. Allegretti, M. De Sario, A. D'Orazio, A. Di Tommaso, T. Palmisano, V. Petruzzelli, Politecnico di Bari (Italy)
- 7598 1B **Chromium-doped zinc selenide gain media: from synthesis to pulsed mid-infrared laser operation (Invited Paper)** [7598-46]
A. Sennaroglu, Koç Univ. (Turkey); U. Demirbas, Koç Univ. (Turkey) and Massachusetts Institute of Technology (United States); H. Cankaya, N. Cizmeciyan, Koç Univ. (Turkey); A. Kurt, Teknofil, Inc. (Turkey); M. Somer, Koç Univ. (Turkey)
- 7598 1C **Pulsed cladding-pumped large mode area fiber Raman amplifier** [7598-47]
J. Ji, C. A. Codemard, J. Sahu, J. Nilsson, Univ. of Southampton (United Kingdom)

SESSION 12 LASER AND AMPLIFIERS II

- 7598 1D **Rogue waves in femtosecond supercontinuum generation** [7598-49]
M. Erkintalo, G. Genty, Tampere Univ. of Technology (Finland); J. M. Dudley, Univ. de Franche-Comté (France)
- 7598 1E **Terrace-microsphere lasers: spherical cavity lasers for multiwavelength emission** [7598-50]
H. Uehara, T. Yano, S. Shibata, Tokyo Institute of Technology (Japan)

POSTER SESSION

- 7598 1H **Direct surface relief formation in As-S(Se) layers** [7598-53]
M. Trunov, Uzhgorod National Univ. (Ukraine); P. Lytvyn, V. Lashkaryov Institute of Semiconductor Physics (Ukraine); P. M. Nagy, Central Institute of Chemical Researches (Hungary); Cs. Cserhati, I. Charnovich, S. Kokenyesi, The Univ. of Debrecen (Hungary)
- 7598 1J **Potentials of the acousto-optical spectral data processing on a basis of a novel algorithm of the collinear wave heterodyning in a large-aperture KRS-5 crystalline cell** [7598-55]
A. S. Shcherbakov, Instituto Nacional de Astrofísica, Óptica y Electrónica (Mexico); J. Maximov, Molecular Technology GmbH (Germany); D. Sanchez Lucero, Instituto Nacional de Astrofísica, Óptica y Electrónica (Mexico)
- 7598 1K **Some peculiarities of designing the optical scheme of tellurium dioxide crystalline cell based acousto-optical spectrometer for the Mexican Large Millimeter Telescope** [7598-56]
A. S. Shcherbakov, D. Sanchez Lucero, A. Luna Castellanos, Instituto Nacional de Astrofísica, Óptica y Electrónica (Mexico); J. Maximov, Molecular Technology GmbH (Germany)
- 7598 1L **Excitation wavelength dependence of quantum efficiencies of Nd-doped glasses for solar pumped fiber lasers** [7598-57]
T. Suzuki, H. Kawai, H. Nasu, M. Hughes, Toyota Technological Institute (Japan); S. Mizuno, K. Hasegawa, H. Ito, Toyota Central Research and Development Labs., Inc. (Japan); Y. Ohishi, Toyota Technological Institute (Japan)
- 7598 1M **Ultraflat supercontinuum generation in an As₂S₃-based chalcogenide core microstructured fiber** [7598-58]
X. Yan, C. Chaudhari, G. Qin, M. Liao, T. Suzuki, Y. Ohishi, Toyota Technological Institute (Japan)
- 7598 1N **Optical parametric amplification in composite tellurite-fluorophosphate fiber** [7598-59]
C. Chaudhari, T. Suzuki, Y. Ohishi, Toyota Technological Institute (Japan)
- 7598 1P **Electronic polarizability and optical parameters of Er³⁺/Yb³⁺ co-doped phosphate glasses** [7598-61]
F. Song, C. Ming, W. Wang, L. Luo, Nankai Univ. (China)
- 7598 1R **Polymer microlens array with tunable focal intensity by the polarization control of the incident light** [7598-63]
S.-Y. Huang, T.-C. Tung, S.-W. Ko, C.-L. Ting, H.-C. Jau, M.-S. Li, H.-C. Lin, A. Y.-G. Fuh, National Cheng Kung Univ. (Taiwan)
- 7598 1S **Fabrication of one-dimensional SWS on bismuth borate glass by glass-imprinting method** [7598-64]
N. Yamashita, Isuzu Glass Co., Ltd. (Japan) and National Institute of Advanced Industrial Science and Technology (Japan); T. Suetsugu, Isuzu Glass Co., Ltd. (Japan); N. Kitamura, K. Fukumi, National Institute of Advanced Industrial Science and Technology (Japan); J. Nishii, Hokkaido Univ. (Japan)
- 7598 1T **A small and fast SCPEM-based ellipsometer** [7598-65]
F. Bammer, Technische Univ. Wien (Austria); R. Petkovšek, J. Možina, J. Petelin, Univ. of Ljubljana (Slovenia)

- 7598 1W **Birefringence control of pigtails in fiber optic devices** [7598-68]
D. Tentori, Ctr. de Investigación Científica y de Educación Superior de Ensenada (Mexico); C. Ayala-Díaz, Univ. Autónoma de Baja California (Mexico); F. Treviño Martínez, Univ. Autónoma de Nuevo León (Mexico)
- 7598 1X **AIN antiresonant layer ARROW waveguides** [7598-69]
M. V. Pelegrini, D. O. Carvalho, M. I. Alayo, I. Pereyra, Univ. de São Paulo (Brazil)
- 7598 1Y **Steep and flat bandpass filter using linearly chirped and apodized fiber Bragg grating** [7598-70]
X. Wu, J. Jacquet, Supélec, Lab. Matériaux Optiques Photonique et Systèmes, CNRS (France); G. Duan, Alcatel-Thalès III-V Lab. (France)
- 7598 20 **Spectroscopy of Yb:Yb doped tellurite glasses for efficient infrared fiber laser** [7598-72]
H. Gebavi, Politecnico di Torino (Italy); M. Taher, Swansea Univ. (United Kingdom); J. Lousteau, D. Milanese, Politecnico di Torino (Italy); S. Taccheo, Swansea Univ. (United Kingdom); A. Schulzgen, College of Optical Sciences, The Univ. of Arizona (United States); M. Ferraris, Politecnico di Torino (Italy); N. Peyghambarian, College of Optical Sciences, The Univ. of Arizona (United States)
- 7598 21 **NIR to visible upconversion in rare-earth ion-doped NaYF₄ crystals** [7598-73]
D. Patel, C. Vance, N. King, M. Jessup, L. Green, Oakwood Univ. (United States); S. Sarkisov, SSS Optical Technologies (United States)
- 7598 22 **Detector development for x-ray imaging** [7598-76]
M. A. Mentzer, U.S. Army Aberdeen Test Ctr. (United States); D. A. Herr, Jacobs Aberdeen Test Support Services (United States); K. J. Brewer, U.S. Army Aberdeen Test Ctr. (United States); N. Ojason, H. A. Tarpine, Jacobs Aberdeen Test Support Services (United States)

Author Index

Conference Committee

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- 1 Gain Materials I
Joaquín Fernández, Universidad del País Vasco (Spain)
- 2 Gain Materials II
Aydogan Ozcan, University of California, Los Angeles (United States)
- 3 Silicon Technology
John W. Glesener, L-3 Electro-Optical Systems (United States)
- 4 Optical Fibers and Devices I
Jie Yao, B&W Tek, Inc. (United States)
- 5 Optical Fibers and Devices II
Michel J. F. Digonnet, Stanford University (United States)
- 6 Photonic Devices I
Michel J. F. Digonnet, Stanford University (United States)
- 7 Photonic Devices II
Qing Wang, AdValue Photonics, Inc. (United States)
- 8 Detector Technologies I
John W. Glesener, L-3 Electro-Optical Systems (United States)
- 9 Detector Technologies II
John W. Glesener, L-3 Electro-Optical Systems (United States)
- 10 Semiconductor Lasers and Amplifiers
Xianghua Zhang, Université de Rennes 1 (France)
- 11 Laser and Amplifiers I
Michel J. F. Digonnet, Stanford University (United States)
- 12 Laser and Amplifiers II
Jean-Luc Adam, Université de Rennes 1 (France)